

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/516,805	FENOUIL ET AL.		
Examiner	Art Unit		
Jafar Parsa	1621		

SEARCHED					
Class	Subclass	Date	Examiner		
518	702-705	4/15/2007	JP		
518	715	4/15/2007	JP		
208	58	4/15/2007	JP		

TNI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
518	702-705	4/15/2007	JP		
518	715	4/15/2007	JP		
208	58	4/15/2007	JP		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST/2006-PRESENT	4/15/2007	JP		
INVENTOR NAME SEARCH	4/15/2007	JP		
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